Front Matter: Volume 10153
Advanced Laser Manufacturing Technology

Bingheng Lu
Huaming Wang
Editors

9–11 May, 2016
Beijing, China

Organized by
Chinese Society for Optical Engineering (CSOE) (China)
Photoelectronic Technology Committee, Chinese Society of Astronautics (China)
Photo-electronic Industrialization Committee, CHIA (China)
Department of Cooperation and Coordination for Industry, Academe and Research, CHIA (China)

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Volume 10153
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Please use the following format to cite material from these proceedings:


ISSN: 0277-786X
ISSN: 1996-756X (electronic)
ISBN: 9781510607644

Published by
SPIE
P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
SPIE.org

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Contents

vii Authors
ix Conference Committees
xi Introduction

ADVANCED LASER MANUFACTURING TECHNOLOGY

10153 01 Delay time dependence of thermal effect of combined pulse laser machining [10153-8]
10153 02 Analysis of the spontaneous Rayleigh-Brillouin scattering spectra of N₂ [10153-9]
10153 03 Attenuation characteristic of UWB signals propagation in free space [10153-10]
10153 04 Algorithm research on infrared imaging target extraction based on GAC model [10153-11]
10153 05 Distance measurement to high remote targets based on the airborne chaotic laser [10153-12]
10153 06 Laser pulse peak holding circuit for low cost laser tracking applications [10153-13]
10153 07 The feature extraction of "cat-eye" targets based on bi-spectrum [10153-15]
10153 08 Dual station visualization measuring method of LRCS [10153-16]
10153 09 Fast computation of radiation pressure force exerted by multiple laser beams on red blood cell-like particles [10153-17]
10153 0A Photoacoustic signals denoising of the glucose aqueous solutions using an improved wavelet threshold method [10153-18]
10153 0B Simulation study on thermal effect of long pulse laser interaction with CFRP material [10153-19]
10153 0C Coherence length tunable solid-state lasers based on Fabry-Perot etalon [10153-20]
10153 0D Study of fuzzy adaptive PID controller on thermal frequency stabilizing laser with double longitudinal modes [10153-21]
10153 0E Application research of rail transit safety protection based on laser detection [10153-22]
10153 0F Two dimension interferometric Rayleigh scattering velocimetry [10153-23]
10153 0G Research on the method of precise alignment technology of atmospheric laser communication [10153-24]
Observation of the Impact of angle of cylinder wedge on wedge waves by laser ultrasound technique [10153-25]

Application of lap laser welding technology on stainless steel railway vehicles [10153-26]

Detection of cat-eye effect echo based on unit APD [10153-27]

Optical property of few-mode fiber with non-uniform refractive index for cylindrical vector beam generation [10153-29]

Optical system design of subminiature endoscope with imaging fiber bundle [10153-30]

Study of laser location based on four-quadrant detector APD [10153-31]

Application of drive circuit based on L298N in direct current motor speed control system [10153-32]

Objective backscattering properties measurements at 2.52 terahertz [10153-33]

Controlling software development of CW terahertz target scattering properties measurements based on LabVIEW [10153-34]

Simulation research on 2.52THz radar cross section of conductive column array [10153-35]

The optimizations of CGH generation algorithms based on multiple GPUs for 3D dynamic holographic display [10153-36]

Hybrid modulation driving power technology for pulsed laser fuze [10153-37]

Design of high-precision ranging system for laser fuze [10153-38]

Design of drive circuit of laser diode [10153-40]

Comparative research on the methods for measuring the mode deflection angle of cylindrical resonator gyroscope [10153-41]

Laser positioning of four-quadrant detector based on pseudo-random sequence [10153-43]

Theoretical analysis of temperature response of the fiber Bragg grating embedded in composite insulator [10153-42]

Effect on operating distance of laser rangefinders with deviation between axis of emitting and receiving in turbulent atmosphere [10153-44]

Experimental study of 248nm excimer laser etching of alumina [10153-45]

Transient elastic deformation detection on the metal surface induced by nanosecond laser pulse [10153-46]

An ultra-narrow-band optical filter based on whispering-gallery-mode hybrid-microsphere-cavity [10153-47]
Research on the efficiency of coherent balanced detection [10153-49]

Dynamic calibration technique for inertial navigation system based on one-dimensional laser Doppler velocimeter [10153-50]

The design of Gaussian beam zoom system in intermediate and long distance measurement [10153-51]

Simulation and experiment of near-field nanostructuring on Ti-6Al-4V surface [10153-53]

Improved pulse laser ranging algorithm based on high speed sampling [10153-52]

Research on marking lines of silicone elastomer PDMS for super-hydrophobic surface fabrication based on picosecond laser [10153-54]

A colour image reproduction framework for 3D colour printing [10153-55]

Laser range profile of cones [10153-56]

High speed sampling circuit design for pulse laser ranging [10153-58]
Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Ai, Yong, 12
Cao, Ercong, 0M, 0W
Cao, Guohuaa, 0B
Chen, De-Ying, 0O, 0P, 0Q
Chen, Jian, 0G
Chen, Qian, 0M
Chen, Shanshan, 0T
Chen, Wen, 0X
Chen, Wen-jian, 0G
Chen, Yang, 12
Chen, Yong, 06
Chen, Yu-dan, 0Y
Dong, Shiyun, 17
Dong, Xiaopeng, 0X
Duan, Yuan-yuan, 0G
Fan, Chang-Kun, 0O, 0P
Fan, Guihua, 07
Fan, Youchen, 04
Fan, Yuanyuan, 0C
Fan, Zhenfang, 0V
Fang, Xiaodong, 0Z
Gang, Xiao, 17
Gao, Chunfeng, 13
Gao, Wei, 0G
Gao, Xuan-qi, 16, 1A
Gong, Lei, 19
Gong, Yanjun, 19
Gou, Ming-Jiang, 09
Gu, Guohua, 0M, 0W
Guo, Hai-chao, 16, 1A
Guo, Xiao-kang, 16, 1A
Guo, Xing, 0M
Han, Qingbang, 0H
Han, Sen, 0N
He, Guanzhong, 0L
He, Shi-jie, 16, 1A
He, Xingdao, 02
He, Ying-hong, 0L
Hu, Hongtao, 0Z
Hu, Wen-Gang, 0J
Hu, Xiaobo, 0M, 0W
Hu, Zhi-yun, 0F
Huang, Jianyu, 10, 15
Huang, Xuegong, 0U
Huang, Zhonghua, 03
Ji, Fengzhu, 12
Jia, Bing, 0B
Jia, Jing, 0H
Jin, Guangyong, 01, 0B
Kou, Renke, 05
Li, Changjun, 1B
Li, Hongye, 0K
Li, Huan, 16, 1A
Li, Meng, 03
Li, Qi, 0O, 0P, 0Q
Li, Qian, 0Q, 0Q
Li, Ting, 0L
Li, Wei, 0l
Li, Xin, 0R
Li, Yingchun, 04
Li, Yuchen, 0N
Liu, Guodong, 0A
Liu, Hongyang, 12
Liu, Jie, 0J
Liu, Juan, 0R
Liu, Liguo, 0I
Liu, Linqian, 11
Long, Xingwu, 13
Lu, Qingjie, 0N
Lv, Juan, 0L
Lv, Qiongying, 0B
Ma, Jianhui, 0X
Ma, Shi-wei, 0G
Ma, Xiangfang, 0X
Ma, Xiao-long, 0L
Ma, Yao, 01, 0B
Ma, Qingkai, 0D
Pan, Yao, 0V
Qian, Rui-hai, 16, 1A
Qian, Weixian, 0M, 0W
Qian, Xian-mei, 0Y
Qu, Tianliang, 0V
Ran, Yingying, 0U
Ren, Zhong, 0A
Shao, Jingzhen, 0Z
Shao, Jun, 0F
Shen, Zhonghua, 0H
Sheng, Xin-Qing, 09
Shi, Lin, 10, 15
Si, Jinhai, 0F
Sohiab, Ali, 18
Song, Chaqun, 17
Song, Xingliang, 0C
Sun, Bing, 0K
Sun, Hao, 0N
Sun, Huayan, 07
Sun, Pei-qi, 18
Tang, Yanqin, 0W
<table>
<thead>
<tr>
<th>Name</th>
<th>Code</th>
</tr>
</thead>
<tbody>
<tr>
<td>Tong, Yanqun</td>
<td>10, 15</td>
</tr>
<tr>
<td>Wan, Hongdan</td>
<td>0K, 11</td>
</tr>
<tr>
<td>Wang, Bin</td>
<td>17</td>
</tr>
<tr>
<td>Wang, Chunsheng</td>
<td>0I</td>
</tr>
<tr>
<td>Wang, Dongya</td>
<td>0V</td>
</tr>
<tr>
<td>Wang, Fang</td>
<td>0N</td>
</tr>
<tr>
<td>Wang, Haiyan</td>
<td>0S</td>
</tr>
<tr>
<td>Wang, Hongxiao</td>
<td>0I</td>
</tr>
<tr>
<td>Wang, Jia</td>
<td>11</td>
</tr>
<tr>
<td>Wang, Kai</td>
<td>0V</td>
</tr>
<tr>
<td>Wang, Mengcheng</td>
<td>14</td>
</tr>
<tr>
<td>Wang, Mingjun</td>
<td>19</td>
</tr>
<tr>
<td>Wang, Qi</td>
<td>13</td>
</tr>
<tr>
<td>Wang, Qian</td>
<td>0C</td>
</tr>
<tr>
<td>Wang, Quanzhao</td>
<td>0N</td>
</tr>
<tr>
<td>Wang, Qun</td>
<td>13</td>
</tr>
<tr>
<td>Wang, Sheng</td>
<td>0F</td>
</tr>
<tr>
<td>Wang, Xi</td>
<td>0Z</td>
</tr>
<tr>
<td>Wang, Xiaonan</td>
<td>0X</td>
</tr>
<tr>
<td>Wang, Yangqing</td>
<td>0I</td>
</tr>
<tr>
<td>Wang, Yanyan</td>
<td>0V</td>
</tr>
<tr>
<td>Wang, Yongtian</td>
<td>0R</td>
</tr>
<tr>
<td>Wang, Zhifei</td>
<td>0E</td>
</tr>
<tr>
<td>Wei, Guo</td>
<td>13</td>
</tr>
<tr>
<td>Wu, Dong-Sheng</td>
<td>0J</td>
</tr>
<tr>
<td>Wu, Tao</td>
<td>02</td>
</tr>
<tr>
<td>Wu, Xiaoyi</td>
<td>10, 15</td>
</tr>
<tr>
<td>Wu, Xueming</td>
<td>0S</td>
</tr>
<tr>
<td>Wuerger, Sophie</td>
<td>18</td>
</tr>
<tr>
<td>Xia, Ruxiao</td>
<td>02</td>
</tr>
<tr>
<td>Xiao, Kaida</td>
<td>18</td>
</tr>
<tr>
<td>Xiong, Zhuhua</td>
<td>0A</td>
</tr>
<tr>
<td>Xu, Guangming</td>
<td>0V</td>
</tr>
<tr>
<td>Xu, Ji</td>
<td>11</td>
</tr>
<tr>
<td>Xu, Xiaobin</td>
<td>0S, 0T, 0U</td>
</tr>
<tr>
<td>Xue, Bin</td>
<td>0L</td>
</tr>
<tr>
<td>Yan, Shixing</td>
<td>17</td>
</tr>
<tr>
<td>Yan, Xing-tao</td>
<td>0L</td>
</tr>
<tr>
<td>Yan, Yining</td>
<td>0D</td>
</tr>
<tr>
<td>Yang, Cheng</td>
<td>0N</td>
</tr>
<tr>
<td>Yang, Dan</td>
<td>0R</td>
</tr>
<tr>
<td>Yang, Fan</td>
<td>0X</td>
</tr>
<tr>
<td>Yang, Ming-Lin</td>
<td>09</td>
</tr>
<tr>
<td>Yang, Xiaobo</td>
<td>12</td>
</tr>
<tr>
<td>Yang, Zhe</td>
<td>0Y</td>
</tr>
<tr>
<td>Yates, Julian M.</td>
<td>18</td>
</tr>
<tr>
<td>Yin, Jian-lin</td>
<td>0Y</td>
</tr>
<tr>
<td>Yin, Liuliu</td>
<td>0N</td>
</tr>
<tr>
<td>Ying, Jia-Ju</td>
<td>0J</td>
</tr>
<tr>
<td>Yu, Huan</td>
<td>02</td>
</tr>
<tr>
<td>Yuan, Boshi</td>
<td>01, 0B</td>
</tr>
<tr>
<td>Zeng, Xiao</td>
<td>0X</td>
</tr>
<tr>
<td>Zhang, Chu</td>
<td>0Y</td>
</tr>
<tr>
<td>Zhang, He</td>
<td>0S, 0T</td>
</tr>
<tr>
<td>Zhang, Lin</td>
<td>0K</td>
</tr>
<tr>
<td>Zhang, Peng</td>
<td>0J</td>
</tr>
<tr>
<td>Zhang, Tao</td>
<td>0D</td>
</tr>
<tr>
<td>Zhang, Tinghua</td>
<td>07</td>
</tr>
<tr>
<td>Zhang, Wei</td>
<td>01, 06</td>
</tr>
<tr>
<td>Zhang, Xiangjin</td>
<td>06</td>
</tr>
<tr>
<td>Zhang, Xina</td>
<td>08</td>
</tr>
<tr>
<td>Zhang, Xinyi</td>
<td>02</td>
</tr>
<tr>
<td>Zhang, Yan-mei</td>
<td>16, 1A</td>
</tr>
<tr>
<td>Zhang, Yingxi</td>
<td>0R</td>
</tr>
<tr>
<td>Zhang, Zuxing</td>
<td>0K</td>
</tr>
<tr>
<td>Zhao, Xiaodan</td>
<td>12</td>
</tr>
<tr>
<td>Zhao, Yong-Peng</td>
<td>0O, 0P, 0Q</td>
</tr>
<tr>
<td>Zhou, Bing</td>
<td>0Y</td>
</tr>
<tr>
<td>Zhou, Jian</td>
<td>14</td>
</tr>
<tr>
<td>Zhou, Wenzhen</td>
<td>19</td>
</tr>
<tr>
<td>Zhou, Yi</td>
<td>0C, 0O, 0P</td>
</tr>
<tr>
<td>Zhu, Haohan</td>
<td>11</td>
</tr>
</tbody>
</table>
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Introduction

We had the great honor of organizing the International Symposium on Advanced Laser Manufacturing Technology 2016. It was truly a great pleasure for us to greet the more than 1000 participants from many different countries who attended the symposium. We firmly believe the symposium will become an important international event in the field of optical technology.

The International Symposium on Advanced Laser Manufacturing Technology is sponsored by Chinese Society for Optical Engineering and China High-tech Industrialization Association (CHIA), organized by Chinese Society for Optical Engineering (CSOE), Photoelectronic Technology Committee, Chinese Society of Astronautics, Photo-electronic Industrialization Committee, CHIA, Department of Cooperation and Coordination for Industry, Academe and Research, CHIA.

The purpose of the symposium is to provide a forum for the participants to report and review innovative ideas and up-to-date progress and developments, and discuss novel approaches to application in the optical field. It is sincerely hoped that the research and development in optical field will be promoted, and the international cooperation sharing the common interest be enhanced.

On behalf of the other co-chairmen, and the Organization Committee of the conference, we would like to heartily thank our sponsors and cooperating organizers for all they have done for the symposium. Thanks also to all the authors for their contributions to the proceedings, to all of the participants and friends for their interest and efforts in helping us to make the symposium possible, to the Program Committee for their effective work and valuable advice, especially the Secretariat, and to the SPIE staff for their tireless efforts and outstanding service in preparing the symposiums and publishing the proceedings.

Bingheng Lu
Huaming Wang